

RECEIVED  
CENTRAL FAX CENTER

SEP 30 2004

L&amp;L-I0232

CERTIFICATION OF MAILING OR FAX TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

By: 

Date: September 30, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/047,013 Confirmation No. 5714  
Applicant : Wolfgang Rösner et al.  
Filed : January 16, 2002  
TC/A.U. : 2826  
Examiner : Fazli Erdem  
Title: : Method for Producing a Vertical Semiconductor  
Transistor Component and Vertical  
Semiconductor Transistor Component  
  
Docket No. : L&L-I0232  
Customer No. : 24131

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

S i r :

In response to the Miscellaneous Action dated September 27, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.